



Application No. 10/813,439
SEC.1140
AMENDMENT AFTER FINAL
November 14, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of : **Mail Stop AF**
Sung-Sok Choi : **Group Art Unit 1763**
Serial No. 10/813,439 : **Examiner Zervigon, Rudy**
Filed March 31, 2004 :

*Please enter w/ PCE
dated 1-8-07
Linda 1-18-07*

**Title: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN
SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT**

AMENDMENT AFTER FINAL

**U.S. Patent and Trademark Office
Customer Window, Mail Stop AF
Randolph Building
401 Dulany Street
Alexandria, VA 22314**

Sir:

**In response to the Office Action dated August 14, 2006, the following
amendments and remarks are submitted:**

**Amendments to the Claims are reflected in the Listing of Claims which
begins on page 2 of this paper.**

Remarks/Arguments begin on page 5 of this paper.